

03560.002856. (35.G2856)

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
	:	Examiner: R. Kim
TOSHIHIKO OUCHI, ET AL.)	
	:	Group Art Unit: 2871
Application No.: 09/903,709)	
	:	
Filed: July 13, 2001)	
	:	
For: SURFACE OPTICAL)	
DEVICE APPARATUS,	:	
METHOD OF FABRICATING)	
THE SAME, AND	:	
APPARATUS USING THE)	
SAME	:	February 14, 2005

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

STATEMENT OF SUBSTANCE OF INTERVIEW

Sir:

Applicants wish to thank the Examiner for the courtesies extended to Applicants' undersigned representative during the personal interview conducted on February 3, 2005.

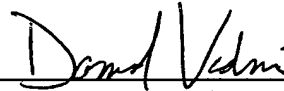
The Examiner and Applicants' representative discussed the Amendment After Final Rejection dated January 18, 2005. The Examiner tentatively agreed that the changes made in the Amendment would overcome the outstanding rejections.

A Request for Continued Examination (RCE) Transmittal requesting consideration of the Amendment is being submitted concurrently herewith.

The application is believed to be in condition for allowance, and a Notice of Allowance is respectfully requested.

Applicants' undersigned attorney may be reached in our Costa Mesa, California office at (714) 540-8700. All correspondence should continue to be directed to our below-listed address.

Respectfully submitted,

A handwritten signature in black ink, appearing to read "Damond E. Vadnais", is written over a horizontal line.

Damond E. Vadnais
Attorney for Applicants
Registration No.: 52,310

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